
SPRING COLLEGE ON SCIENCE AT THE NANOSCALE
(24 May - 11 June 2004)

Nanoscale Transistors: Ultimate Silicon and Beyond

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These are preliminary lecture notes, intended only for distribution to participants.

Spring College on Science at the Nanoscale - Trieste, Italy, June 2004

Nanoscale Transistors: Ultimate silicon and beyond

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Network for Computational Nanotechnology

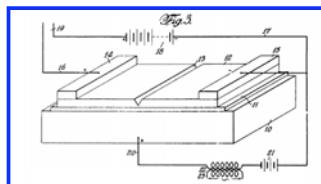
www.nanohub.org



- I) Introduction
- II) Theory
- III) Nanowire MOSFETs
- IV) Nano MOSFETs
- V) Molecular MOSFETs?
- VI) Conclusions

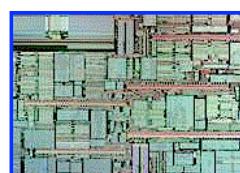
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I) Introduction: FETs

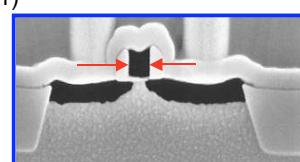


Lillienfield, 1925
Heil, 1935

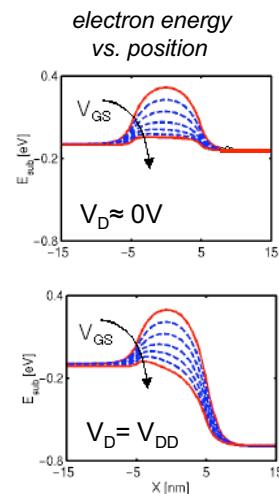
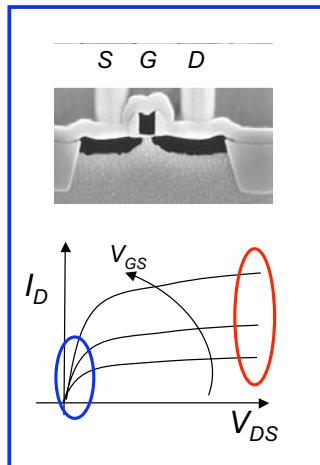
- Si MOSFET, 1960
- PMOS IC's, 1963
- CMOS invented, 1963
- NMOS IC's, 1970



50 nm (2003 production)
5 nm (2003 research)



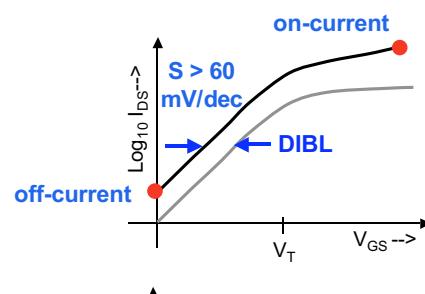
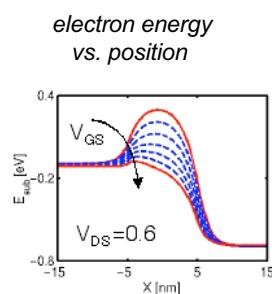
I) Introduction: MOSFET as a BJT in disguise



E.O. Johnson, *RCA Review*, 1971

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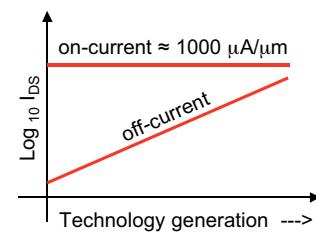
I) Introduction: device metrics



$$I_{ON} \equiv I_D(V_{GS} = V_{DD}, V_{DS} = V_{DD})$$

$$I_{OFF} \equiv I_D(V_{GS} = 0, V_{DS} = V_{DD})$$

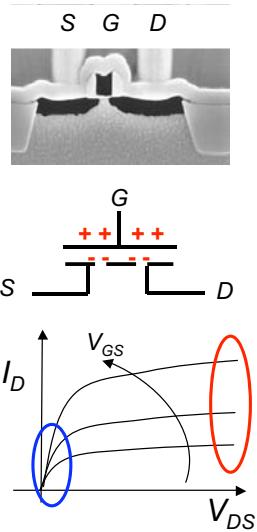
$$S \text{ mV/decade} \quad DIBL \text{ mV/V}$$



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I) Introduction: traditional theory



$$I_D = W Q_n v_x \\ = W C_{ox} (V_{GS} - V_T) \mu_{eff} \mathcal{E}_x$$

i) low V_{DS} :

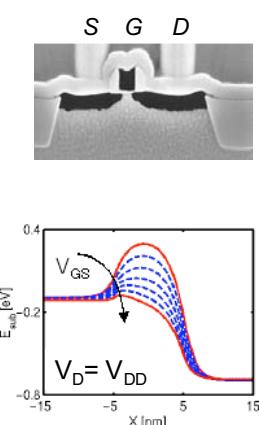
$$\mathcal{E}_x = V_{DS}/L \\ I_D = \left(\frac{W}{L}\right) \mu_{eff} C_{ox} (V_{GS} - V_T) V_{DS}$$

ii) high V_{DS} :

$$\mathcal{E}_x(0) \approx (V_{GS} - V_T)/2L \\ I_D = \frac{W}{2L} \mu_{eff} C_{ox} (V_{GS} - V_T)^2$$

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I) Introduction



$$I_D = Q(x=0) \langle v(x=0) \rangle$$

1) electrostatics:

$$Q(V_G, V_D)$$

2) transport:

$$\langle v(V_G, V_D) \rangle$$

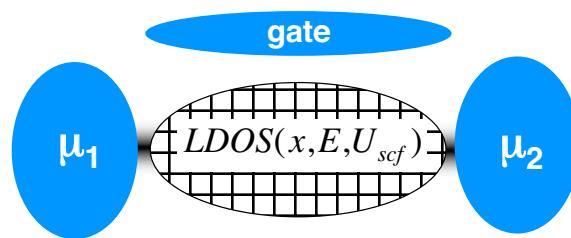
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- I) Introduction
- II) Theory
- III) Nanowire MOSFETs
- IV) Nano MOSFETs
- V) Molecular MOSFETs?
- VI) Conclusions



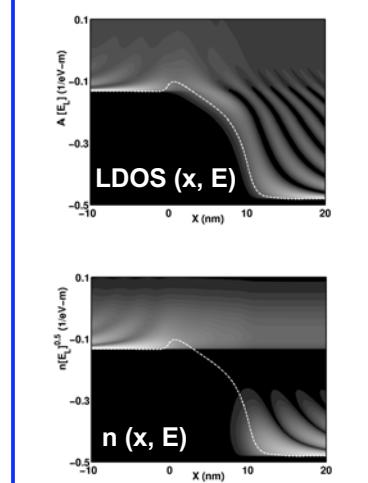
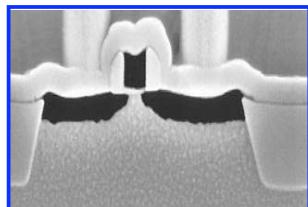
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II) Theory



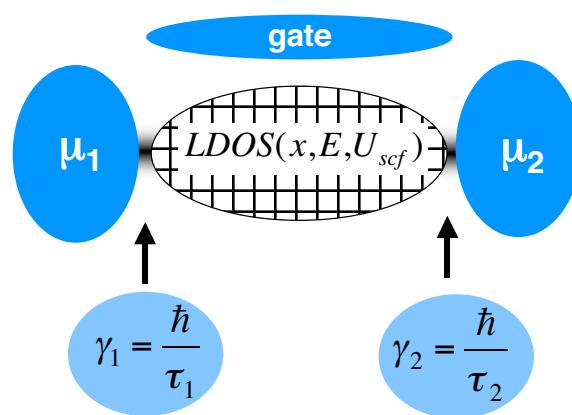
- 1) Electronic states in the device are controlled by the terminal voltages (**electrostatics**)
- 2) States in the device are filled from the two contacts according to their Fermi levels (**transport**)

II) Theory: ballistic quantum transport



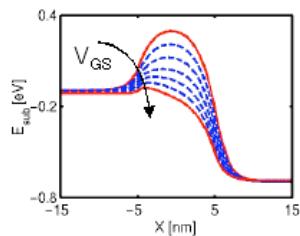
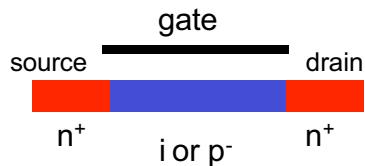
(Ramesh Venugopal, TI)⁹

II) Theory: role of the contacts

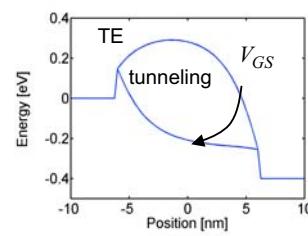
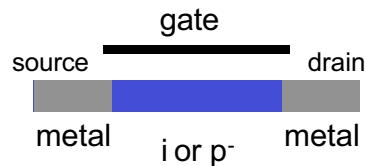


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II) Theory: two kinds of transistors



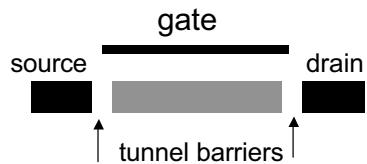
MOSFET



SBFET

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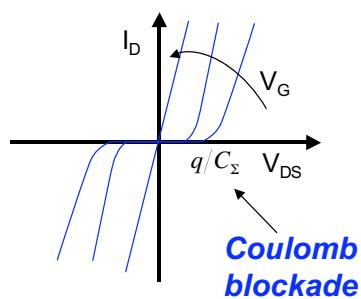
II) Theory: single electron transistors



$$\frac{q^2}{C_\Sigma} > k_B T$$

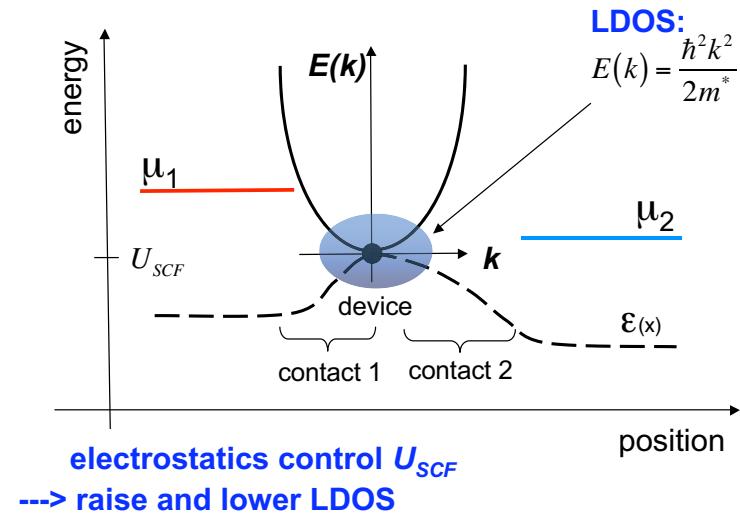
$$\gamma_1, \gamma_2 < k_B T$$

**Requires a particle approach
not a wave approach**



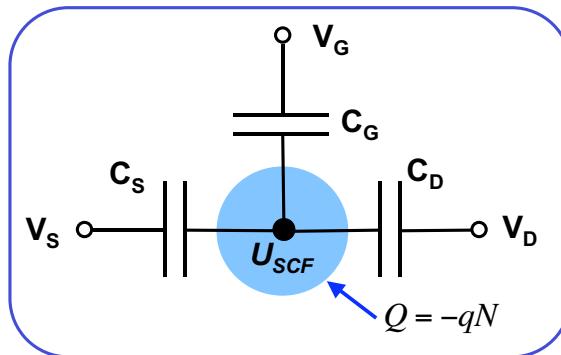
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II) Theory: MOSFETs



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II) Theory: electrostatics

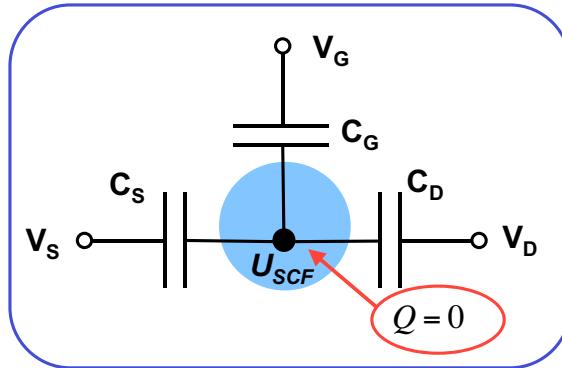


U_{SCF} is controlled by the gate, drain, and source voltages and by the charge in the device

A. Rahman, et al. IEEE TED, Sept., 2003

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II) Theory: electrostatics

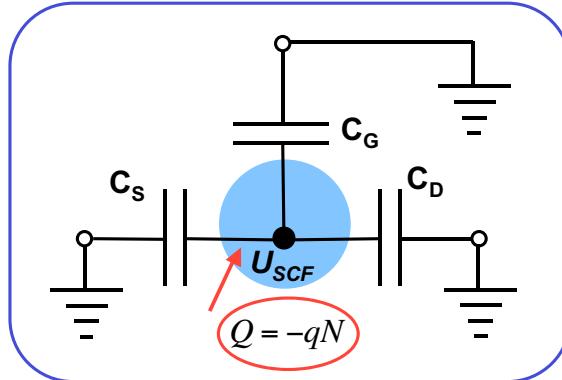


$$U_{Laplace} = -qV_G \left(\frac{C_G}{C_\Sigma} \right) - qV_D \left(\frac{C_D}{C_\Sigma} \right) - qV_S \left(\frac{C_S}{C_\Sigma} \right)$$

$$C_\Sigma = C_G + C_D + C_S$$

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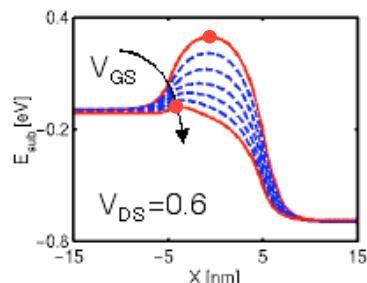
II) Theory: electrostatics



$$U_p = \frac{q^2 N}{C_\Sigma}$$

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II) Theory



FETToy:

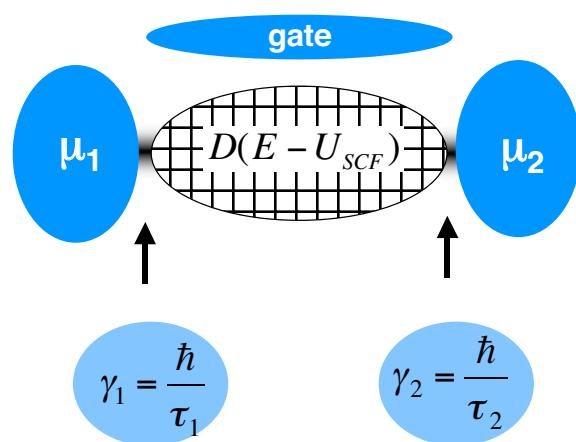
$$U_{SCF}(N) = -qV_G \left(\frac{C_G}{C_\Sigma} \right) - qV_D \left(\frac{C_D}{C_\Sigma} \right) - qV_S \left(\frac{C_S}{C_\Sigma} \right) + \frac{q^2 N(U_{SCF})}{C_\Sigma}$$

well-tempered MOSFET:

$$qN = C_G(V_{GS} - V_T) \quad (V_{GS} > V_T)$$

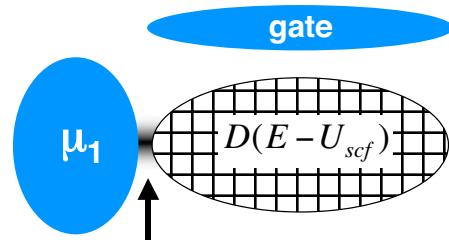
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II) Theory: transport



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II) Theory: filling from the left contact.....



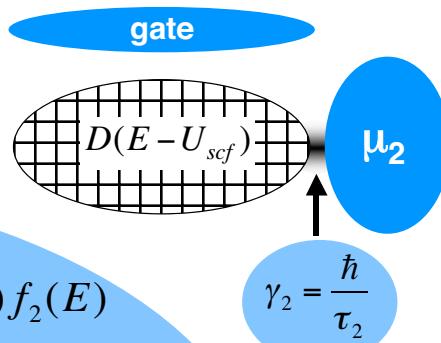
$$\gamma_1 = \frac{\hbar}{\tau_1}$$

(ballistic)

$$N_1(E) = D(E - U_{scf}) f_1(E)$$

$$\frac{dN(E)}{dt} = \frac{N_1(E) - N}{\tau_1}$$

II) Theory: filling from the right contact.....



$$N_2(E) = D(E - U_{scf}) f_2(E)$$

$$\frac{dN(E)}{dt} = \frac{N_2(E) - N}{\tau_2}$$

II) Theory:

$$\frac{dN(E)}{dt} = \frac{N_1 - N}{\tau_1} + \frac{N_2 - N}{\tau_2} = 0 \quad (\text{steady-state})$$

$$N = \int [A_1(E)f_1(E) + A_2(E)f_2(E)] \frac{dE}{2\pi}$$

$$A_1(E) = 2\pi \frac{\gamma_1}{\gamma_1 + \gamma_2} D(E - U_{scf})$$
$$A_2(E) = 2\pi \frac{\gamma_2}{\gamma_1 + \gamma_2} D(E - U_{scf})$$

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II) Theory: steady-state

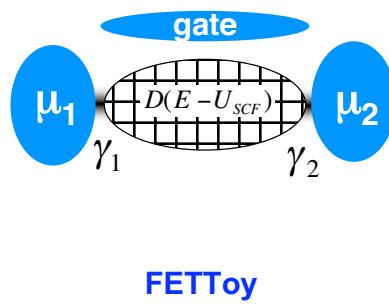
$$I_D = \frac{N_1 - N}{\tau_1} = \frac{-(N_2 - N)}{\tau_2}$$

$$I_D = \frac{2q}{h} \int T(E)(f_1(E) - f_2(E)) dE \quad (\text{Landauer})$$

$$T(E) = \frac{\gamma_1 \gamma_2}{\gamma_1 + \gamma_2} \pi D(E - U_{scf})$$

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II) Theory: summary



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Given:

Device structure (C_G, C_D, C_S , etc)
Contacts (γ_1, γ_2)
 $D(E - U_{SCF})$
 μ_1, μ_2

Compute:

$U_{SCF}(V_{GS}, V_{DS}, N)$
 $N(U_{SCF}, V_{DS})$
 $I_D(U_{SCF}, V_{DS})$

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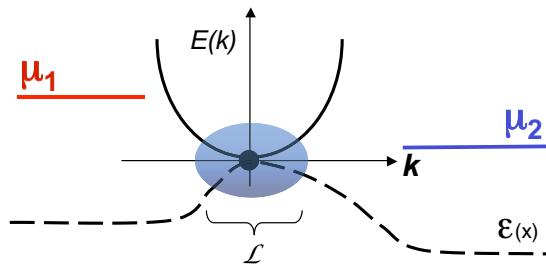
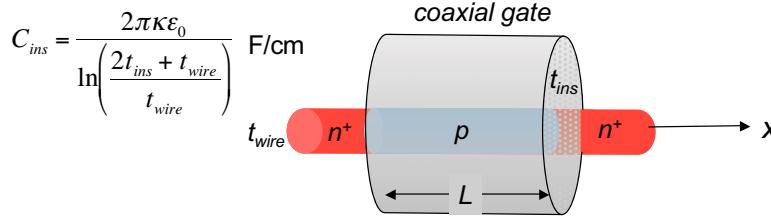
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III) Nanowire MOSFETs



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III) Nanowire MOSFETs

steady-state electron number:

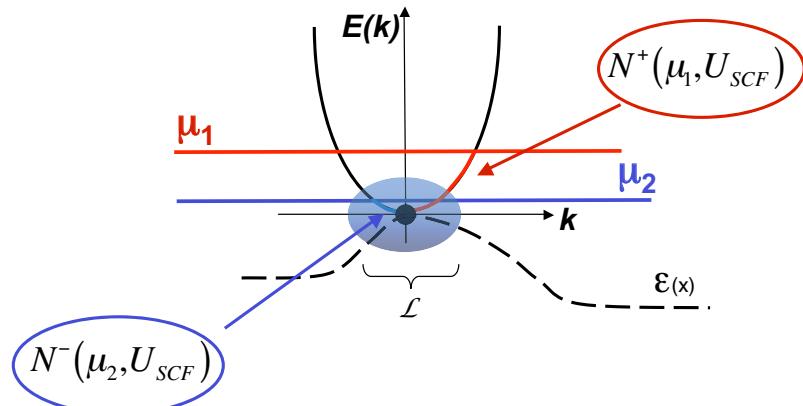
$$N = \int [A_1(E)f_1(E) + A_2(E)f_2(E)] \frac{dE}{2\pi}$$

$$\frac{A_1(E)}{2\pi} = \frac{\gamma_1}{\gamma_1 + \gamma_2} D(E - U_{scf}) = \frac{\mathcal{L}}{2\pi\hbar} \sqrt{\frac{2m^*}{E - \varepsilon}} H(E - U_{scf} - \varepsilon)$$

$$N = N^+(\mu_1) + N^-(\mu_2) = \frac{N_{1D}\mathcal{L}}{2} \mathcal{F}_{-1/2}(\eta_F) + \frac{N_{1D}\mathcal{L}}{2} \mathcal{F}_{-1/2}(\eta_F - U_D)$$

$$\begin{cases} N_{1D} = \sqrt{\frac{2m^*k_B T}{\pi\hbar^2}} & \eta_F = (\mu_1 - \varepsilon_0 - U_{SCF})/k_B T \\ & U_D = qV_D/k_B T \end{cases} \quad 26$$

III) Nanowire MOSFETs



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III) Nanowire MOSFETs: electrostatics

$$\left\{ \begin{array}{l} U_{SCF}(N) = -qV_G \left(\frac{C_G}{C_\Sigma} \right) - qV_D \left(\frac{C_D}{C_\Sigma} \right) - qV_S \left(\frac{C_S}{C_\Sigma} \right) + \frac{q^2 N(U_{SCF})}{C_\Sigma} \\ N(U_{SCF}, \mu_1, \mu_2) = N^+ + N^- = \frac{N_{1D}\mathcal{L}}{2} \mathcal{F}_{-1/2}(\eta_F) + \frac{N_{1D}\mathcal{L}}{2} \mathcal{F}_{-1/2}(\eta_F - U_D) \\ \eta_F = (\mu_1 - \varepsilon_0 - U_{SCF}) / k_B T \end{array} \right.$$

“well-tempered MOSFET”

$$\frac{N}{\mathcal{L}} = \frac{C_{ins}}{q} (V_{GS} - V_T) = \frac{N_{1D}}{2} \mathcal{F}_{-1/2}(\eta_F) + \frac{N_{1D}}{2} \mathcal{F}_{-1/2}(\eta_F - U_D)$$

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III) Nanowire MOSFETs: I_D

$$I_D = \frac{2q}{h} \int T(E) (f_1(E) - f_2(E)) dE$$

$$T(E) = \frac{\gamma_1 \gamma_2}{\gamma_1 + \gamma_2} \pi D (E - U_{scf}) = 1$$

$$\gamma_1 = \gamma_2 = \frac{\hbar}{\tau} = \hbar \frac{v_k}{\mathcal{L}} \quad D(E) = \frac{2}{\pi} \frac{\mathcal{L}}{\hbar v_k}$$

$$I_D = \frac{2qk_B T}{h} \{ \mathcal{F}_0(\eta_F) - \mathcal{F}_0(\eta_F - U_D) \}$$

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III) Nanowire MOSFETs

$$\frac{C_{ins}}{q} (V_{GS} - V_T) = \frac{N_{1D}}{2} \mathcal{F}_{-1/2}(\eta_F) + \frac{N_{1D}}{2} \mathcal{F}_{-1/2}(\eta_F - U_D) \quad (1)$$

$$I_D = \frac{2qk_B T}{h} \{ \mathcal{F}_0(\eta_F) - \mathcal{F}_0(\eta_F - U_D) \} \quad (2)$$

$$I_D = C_{ins} (V_{GS} - V_T) \tilde{v}_T \left\{ \frac{1 - \mathcal{F}_0(\eta_F)/\mathcal{F}_0(\eta_F - U_D)}{1 + \mathcal{F}_{-1/2}(\eta_F)/\mathcal{F}_{-1/2}(\eta_F - U_D)} \right\}$$

$$\tilde{v}_T = \sqrt{\frac{2k_B T}{\pi m^*}} \left(\frac{\mathcal{F}_0(\eta_F)}{\mathcal{F}_{-1/2}(\eta_F)} \right) \quad \text{"injection velocity"}$$

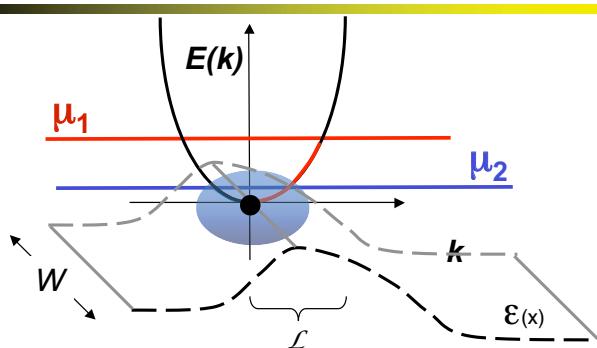
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IV) The nano-MOSFET



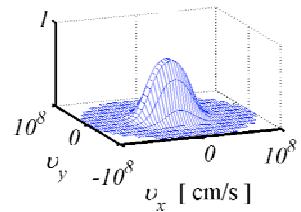
$$N(\mu_1, \mu_2, U_{SCF}) = \int \frac{D(E - U_{SCF})}{2} [f_1(E) + f_2(E)] dE = N^+ + N^-$$
$$D(E - U_{SCF}) = W\mathcal{L} \left(\frac{m^*}{2\pi\hbar} \right) H(E - \varepsilon - U_{SCF})$$

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IV) The nano-MOSFET: filling the states

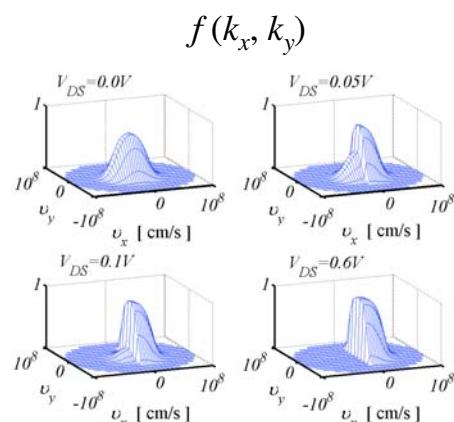
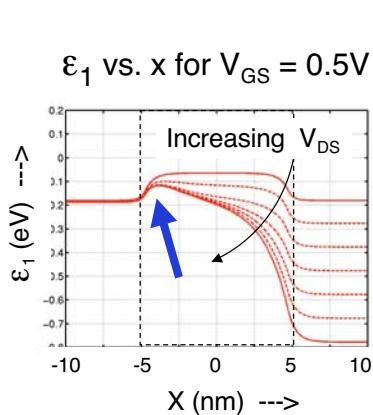
$$f_0 = \frac{1}{1 + e^{(E - E_F)/k_B T}} \approx e^{(E_F - E)/k_B T} = e^{(E_F - E_C)/k_B T} \times e^{m^* v^2 / 2 k_B T}$$

$$f_0 \propto e^{m^* (v_x^2 + v_y^2) / 2 k_B T}$$



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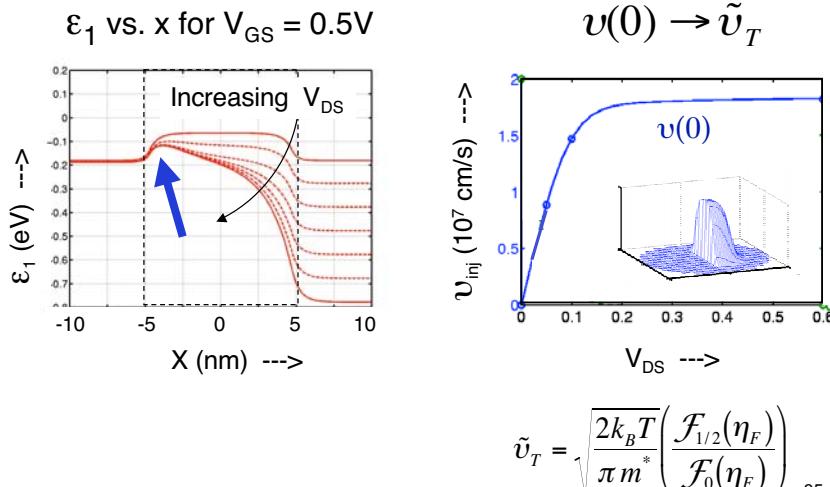
IV) The nano-MOSFET: filling the states



electrostatics: $qN = C_G(V_{GS} - V_T)$

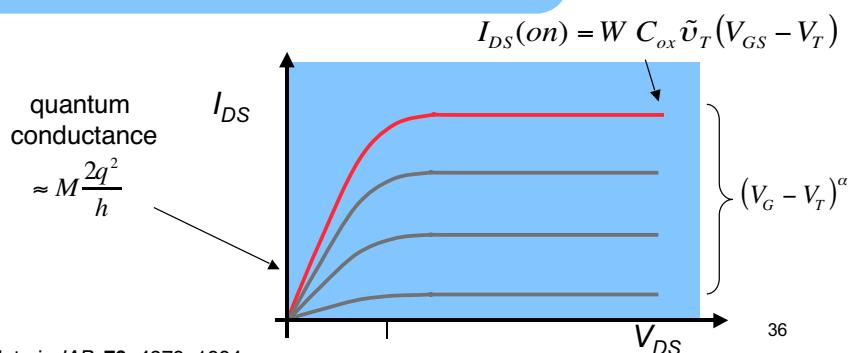
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IV) The nano-MOSFET: velocity saturation

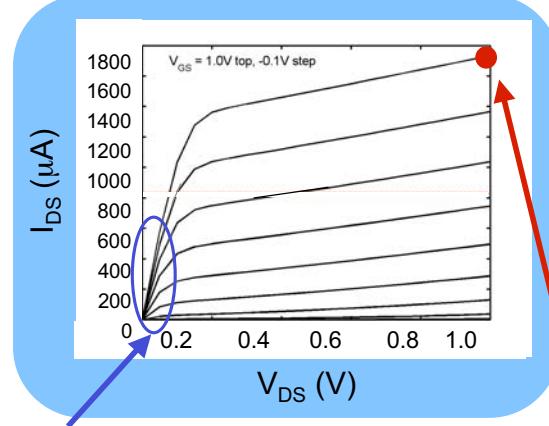


IV) The nano-MOSFET

$$I_{DS} = W C_{ox} (V_{GS} - V_T) \tilde{v}_T \times \left\{ \frac{1 - \frac{\mathcal{F}_{1/2}(\eta_F - U_{DS})}{\mathcal{F}_{1/2}(\eta_F)}}{1 + \frac{\mathcal{F}_0(\eta_F - U_{DS})}{\mathcal{F}_0(\eta_F)}} \right\}$$



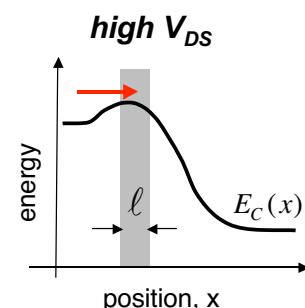
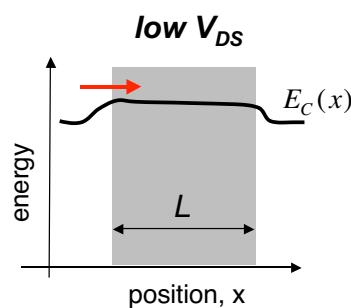
IV) The nano-MOSFET



measured channel conductance
~10% of ballistic limit

measured on-current
~50% of ballistic limit

IV) The nano-MOSFET: scattering



$$T \approx \frac{\lambda_o}{L + \lambda_o} \approx 0.10$$

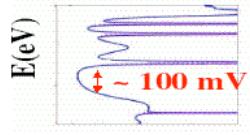
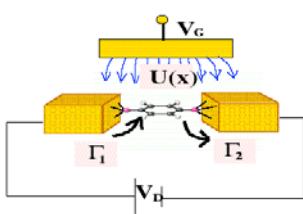
$$T \approx \frac{\lambda_o}{\ell + \lambda_o} \approx 0.50$$

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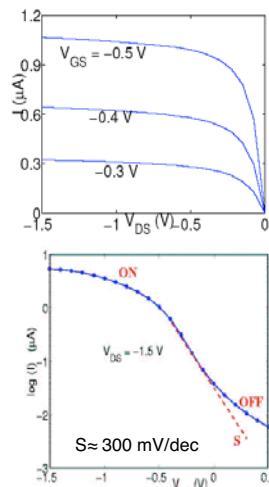


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V) Molecular MOSFETs? Organic Molecular FETs



DOS (/eV)



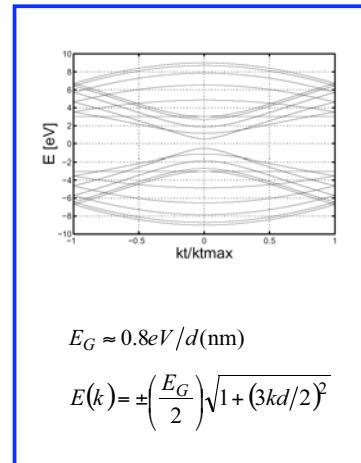
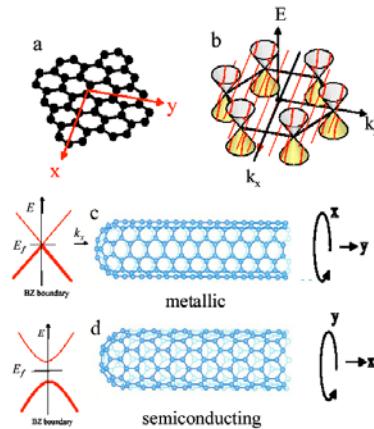
$L \approx 1 \text{ nm}$
 $t_{\text{ox}} \ll L$
 $t_{\text{ox}} \approx 1-2 \text{\AA} !!$

temperature-independent MIGS

S. Datta, A. Ghosh, P. Damle, T. Rakshit

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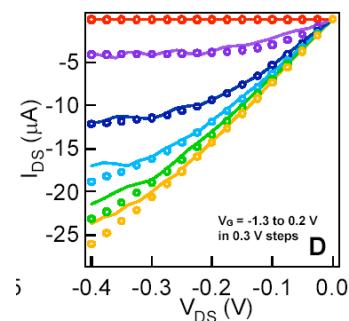
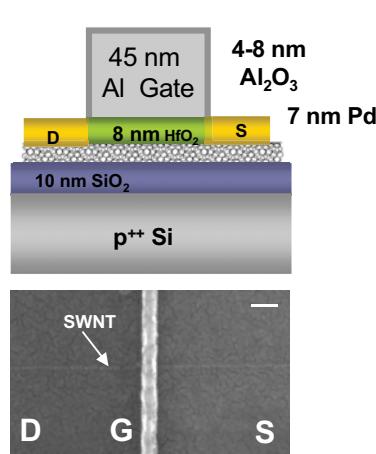
V) Molecular MOSFETs? CNTFETs



McEuen et al., IEEE Trans. Nanotech., 1, 78, 2002.

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V) Molecular MOSFETs?: CNTFETs



$$I(\text{on}) \approx 12 \mu\text{A}$$

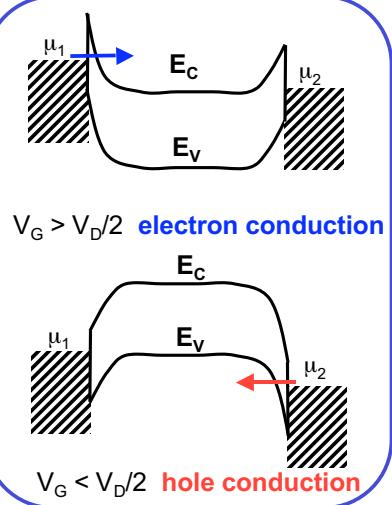
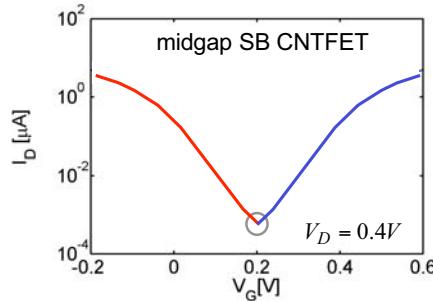
$$S \approx 110 \text{ mV/dec}$$

$$G_D \approx 0.4 G_0$$

Hongjie Dai Group, Stanford

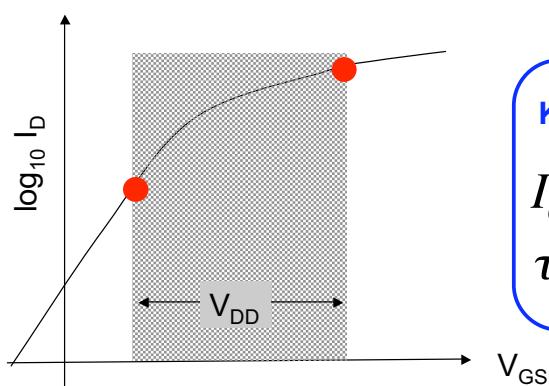
42

V) Molecular MOSFETs? ambipolar conduction



Guo, Datta, and Lundstrom, IEEE TED, Jan. 2004

V) Molecular MOSFETs? CNTFETs vs. MOSFETs



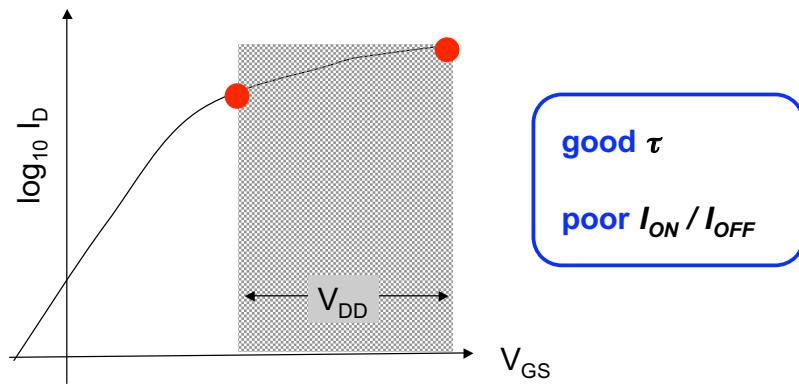
Key device metrics:

$$I_{ON}/I_{OFF}$$

$$\tau = C_G V_{DD} / I_{ON}$$

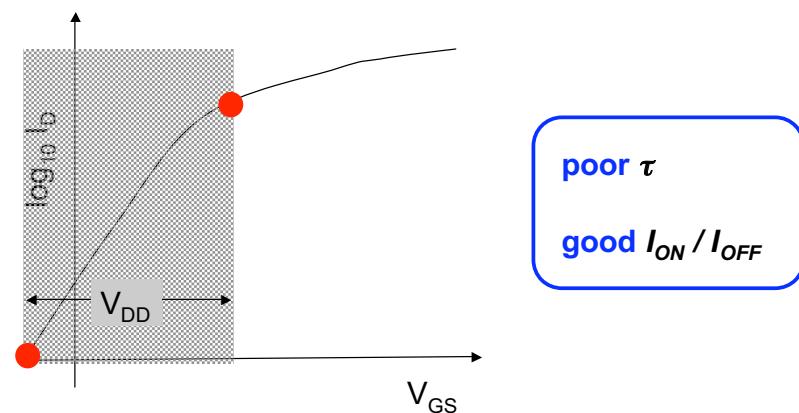
44

V) Molecular MOSFETs? CNTFETs vs. MOSFETs



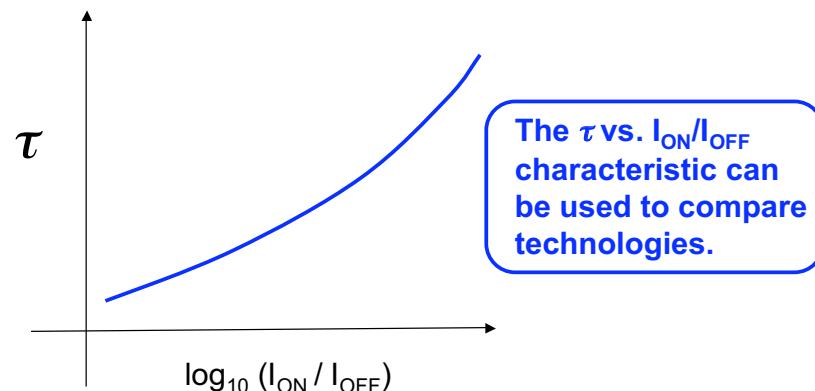
45

V) Molecular MOSFETs? CNTFETs vs. MOSFETs



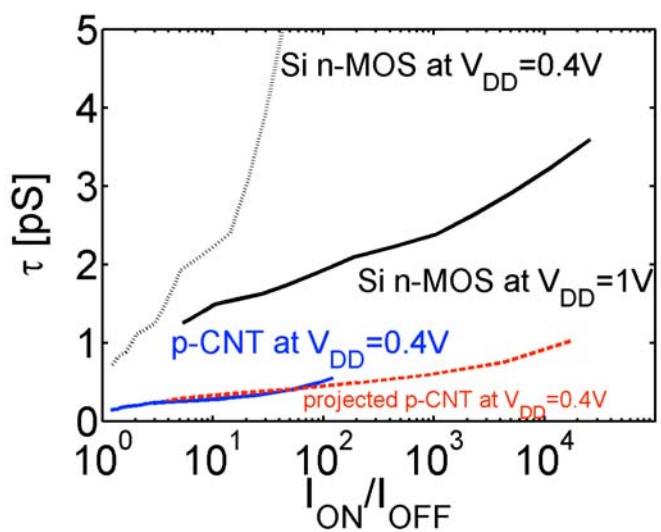
46

V) Molecular MOSFETs? CNTFETs vs. MOSFETs



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V) Molecular MOSFETs? CNTFETs vs. MOSFETs



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Spring College on Science at the Nanoscale - Trieste, Italy, June 2004

- I) Introduction
- II) Theory
- III) Nanowire MOSFETs
- IV) Nano MOSFETs
- V) Molecular MOSFETs?
- VI) Conclusions



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VI) Conclusions

- 1) Ballistic nano-MOSFETs are easy to understand
- 2) Present-day MOSFETs operate at $\sim 50\%$ of the ballistic limit.
- 3) Carbon nanotubes promise improved performance, but....
- 4) At the end of the ITRS, the Si MOSFET will operate close to fundamental limits.